

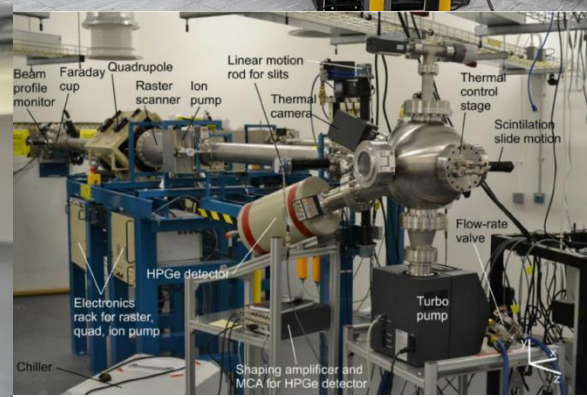
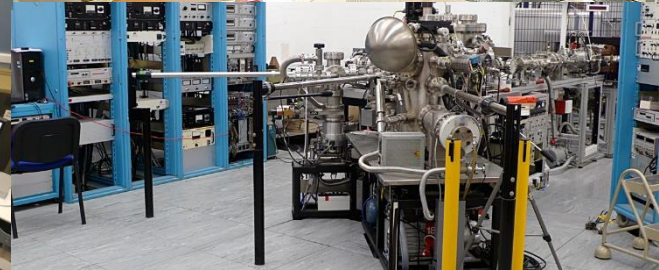
# The UK National Ion Beam Centre

EPSRC



[www.uknibc.co.uk](http://www.uknibc.co.uk)

Roger Webb  
University of Surrey  
Ion Beam Centre





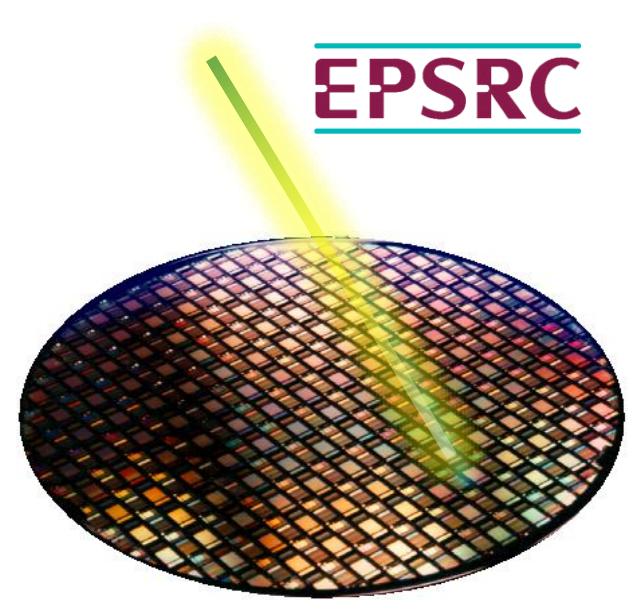
# Ion Implantation

**The charge on the ion** can be collected so that each ion can be counted as it enters the material ensuring precise control on **quantity**

**The charge on the ion** enables a single isotopic mass to be selected in a magnetic field providing **high purity**

**The charge on the ion** enables the particles to be accelerated by a potential gradient. The velocity of each particle is identical and when they reach the target surface will embed themselves to a **well determined depth**.

**The charge on the ion** enables the ion beam to be raster scanned across a target (like an old fashioned CRT display) producing a **very uniform** spread across the sample under irradiation.



# Ion Beam Analysis

What happens when the ion beam hits the target?

## RBS

Energy of scattered protons or He give light element composition and elemental depth profiles

Fast moving, charged particles  
MeV ions

## PIXE

Characteristic X-ray emission  
Simultaneous part-per-million detection of trace elements from Na to U

## PIGE/NRA

Nuclear reactions give characteristic gamma rays and/or particles from light nuclei (e.g. Li, B, F)

## MeV SIMS

Using heavy ions molecular material can be desorbed and analysed using ToF MS

## IBIC

Ion Beam Induced Charge

## STIM

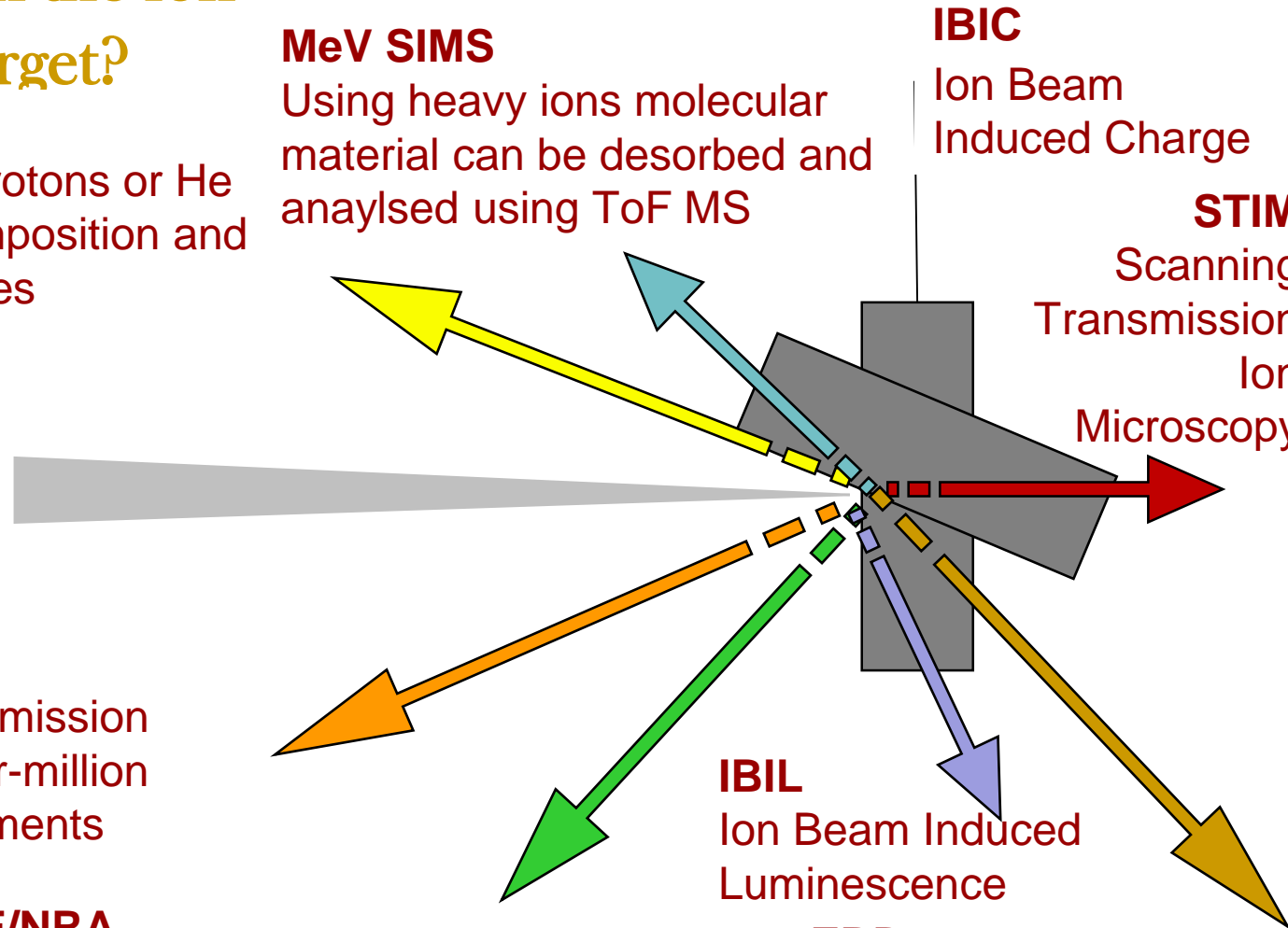
Scanning Transmission Ion Microscopy

## IBIL

Ion Beam Induced Luminescence

## ERD

Forward recoil of target atoms (particularly good for H profiling)





# The UK National Ion Beam Centre

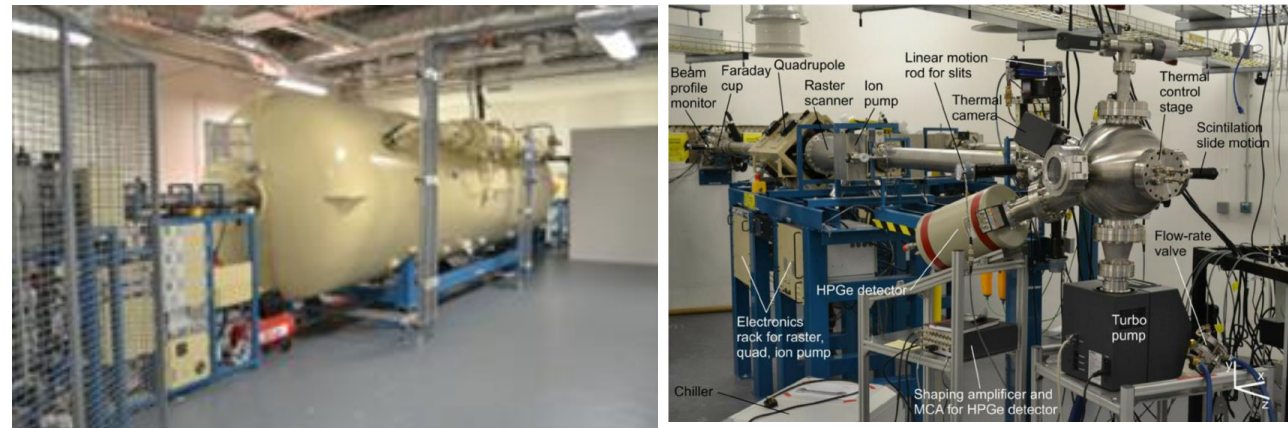
EPSRC



## Bringing together 3 ion beam facilities in the UK



## An EPSRC Mid Range Facility



[www.uknibc.co.uk](http://www.uknibc.co.uk)

# Huddersfield Miami Facility

- **Implanter with In situ TEM**
  - **Facilities**
    - JOEL 2000FX TEM
    - 2-100keV Implanter
    - Temperature stage -173-1000°C
  - **Applications**
    - Nuclear Radiation damage
    - Ion Implantation
  - **Staff**
    - Steve Donnelly
    - Johnathan Hinks
    - Graeme Greaves

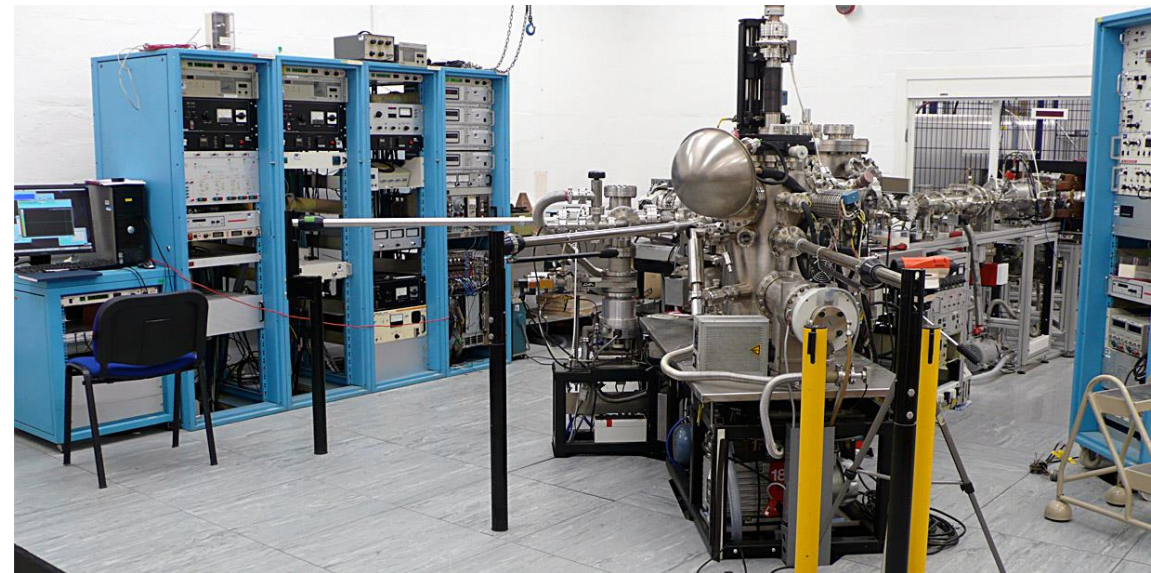


*University of*  
**HUDDERSFIELD**  
 Inspiring tomorrow's professionals



# Huddersfield MEIS Facility

- **Medium Energy Ion Scattering**
  - **Facilities**
    - 50-200keV Accelerator
    - LEED Auger
    - Temp range 300-1300K
  - **Applications**
    - High Resolution Depth Profiling
    - Channelling for damage studies
  - **Staff**
    - Jaap Van Den Berg
    - Roger Barlow



*University of*  
**HUDDERSFIELD**  
Inspiring tomorrow's professionals

- **Cumbrian Nuclear User Facility**

- **Facilities**

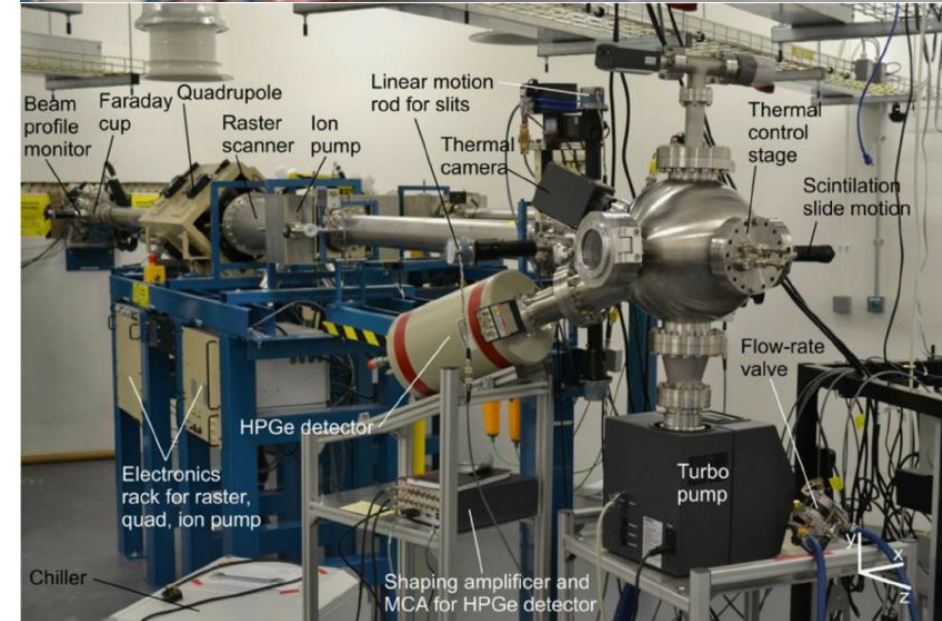
- 5MV Tandem Accelerator
- $^{60}\text{Co}$  gamma source – 4-100Gy/min
- Temp range 300-1300K
- Installing 2.5MV Tandem for dual beam work

- **Applications**

- Radiation Damage Studies
- Nuclear Irradiation

- **Staff**

- Simon Pimblott
- Andy Smith
- Nick Mason



# Surrey Ion Beam Centre

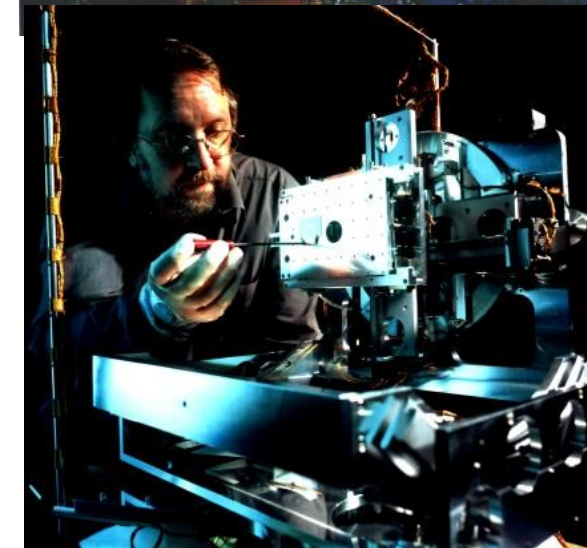
- **Investment**

- **Support**

- £5M investment in machines and beam lines
    - Approx £1.5M per annum support
    - 2 academics
    - 8 RAs (including 2 senior RAs)
    - 3 technicians + 1 secretarial

- **Technology Transfer**

- 32 University departments around the UK
    - 53 local and international companies
    - 15 PhD projects
    - Supporting >50 EPSRC grants worth >£50M





# Surrey Ion Beam Centre

- **Controllable Materials Modification**
  - **Facilities**
    - 0.4-2MV High Energy Implanter
    - 2-200kV High Current Implanter
    - Implantation 2keV $\Rightarrow$ 4MeV (up to 10mA)
    - Sample size mm<sup>2</sup> to 40cmx40cm
    - Hot (1000°C) or cold (~10K)
    - Sample Chambers in class 100 clean room
    - Plasma/thermal processing and metrology

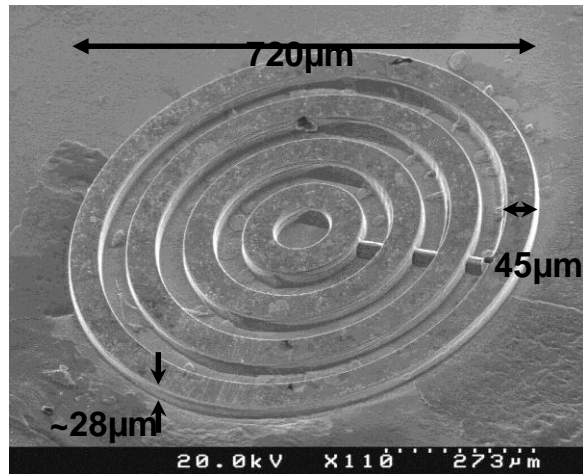
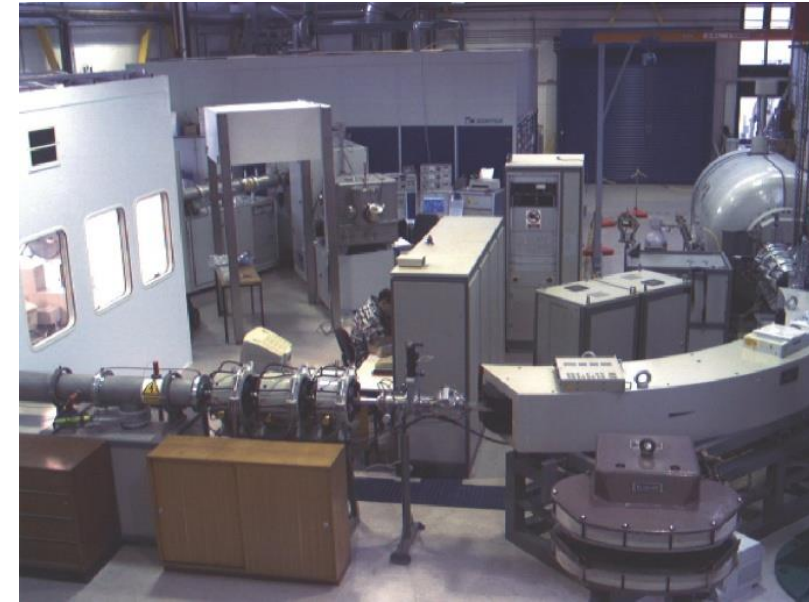


# Surrey Ion Beam Centre

- **Controllable Materials Modification**

- **Applications**

- Ion Beam Synthesis
- Ion Implantation
- Defect Engineering
- Proton beam lithography (on Tandem accelerator)



*SEM image of a concentric circle structure produced by 2MeV protons in GaAs*

[www.uknibc.co.uk](http://www.uknibc.co.uk)

Available Implanted Species

■ 2 - 2000kV  
■ Not Available  
■ Call

H																	He
Li	Be											B	C	N	O	F	Ne
Na	Mg											Al	Si	P	S	Cl	Ar
K	Ca	Sc	Ti	V	Cr	Mn	Fe	Co	Ni	Cu	Zn	Ga	Ge	As	Se	Br	Kr
Rb	Sr	Y	Zr	Nb	Mo	Tc	Ru	Rh	Pd	Ag	Cd	In	Sn	Sb	Te	I	Xe
Cs	Ba	Lu	Hf	Ta	W	Re	Os	Ir	Pt	Au	Hg	Tl	Pb	Bi	Po	At	Rn
Fr	Ra	Lr	Rf	Db	Sg	Bh	Hs	Mt	Ds	Rg	Cn	Uut	Uuq	Uup	Uuh	Uus	Uuo

La	Ce	Pr	Nd	Pm	Sm	Eu	Gd	Tb	Dy	Ho	Er	Tm	Yb	Lu
Ac	Th	Pa	U	Np	Pu	Am	Cm	Bk	Cf	Es	Fm	Md	No	Lw





# Surrey Ion Beam Centre

- **Advanced Materials Analysis**

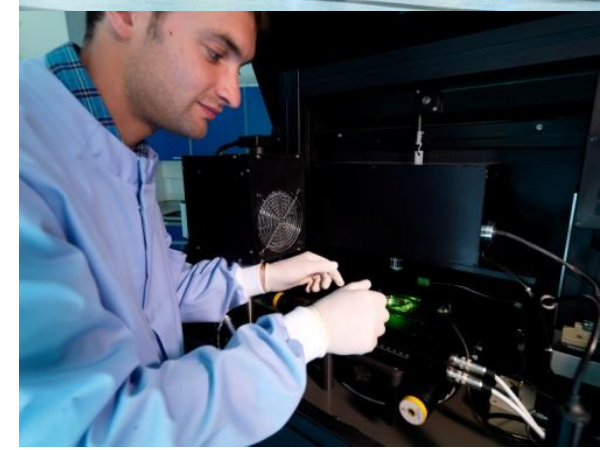
- **Facilities**

- 2MV Tandem
- Techniques include RBS, EBS, ERD, PIXE, PIGE, NRA, IBIL, IBIC
- **NEW** MeV SIMS
- Sub micron size micro-beam with full scanning
- Channelling Spectroscopy for damage analysis
- Fully automated collection and analysis
- External Beam for vacuum sensitive samples
- Horizontal nanobeam (30nm) in construction
- Vertical nanobeam for cell (in culture) irradiation



# Surrey Ion Beam Centre

- **Advanced Materials Analysis**
  - **Applications**
    - Thin Film Depth Profiling
    - 3-D elemental composition and mapping
    - Protein Analysis
    - Forensics, Archaeometry
    - Disorder Profiling of Crystals
    - Radio biology
    - Analysis of cells in culture





# Surrey Ion Beam Centre



## Bio-Irradiation Facility

### Facilities for bio-irradiation

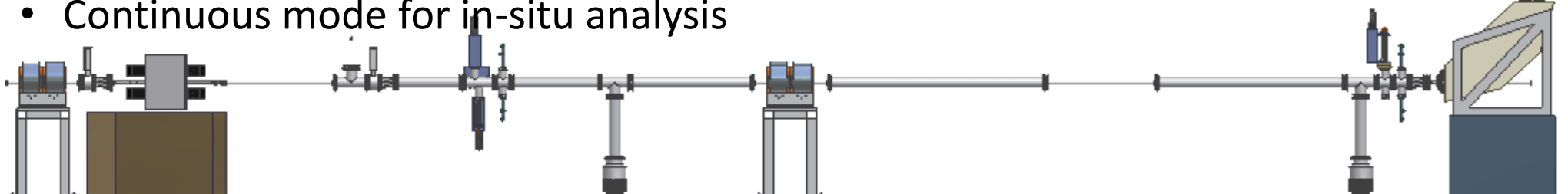
- Targeted ( $\sim 100\text{nm}$ ) single ion irradiation
- End Station in Cat 2 biological clean room
- Vertical Arrangement to allow irradiation of living cells in liquid cultural
- $\sim 10,000$  cell irradiations per hour
- Ions up to Ca from 2MVTandem
- Environmental chamber, incubators etc.

### Facilities for Protein Analysis

- Analysis by microPIXE
- To determine the heavy metal constituents in some proteins – can be difficult via other methods
- ppm sensitivity

### Applications

- Cell Irradiation
- Proton/hadron therapy research
- Continuous mode for in-situ analysis



# Surrey Ion Beam Centre

## Quality Assurance and Standards

- *Extensive QA program*
- *ISO9001 certified since 2008*
- Working with both NPL and PTB on various fundamental studies
- ISO17025 accreditation for high accuracy RBS





# Surrey Ion Beam Centre



## USERS

Other EU Universities accessing the Surrey IBC in the past 5 years include:



UK Universities Accessing the Surrey IBC in the past 5 years include:



National Centres and Organisations accessing the IBC in past 5 years include:

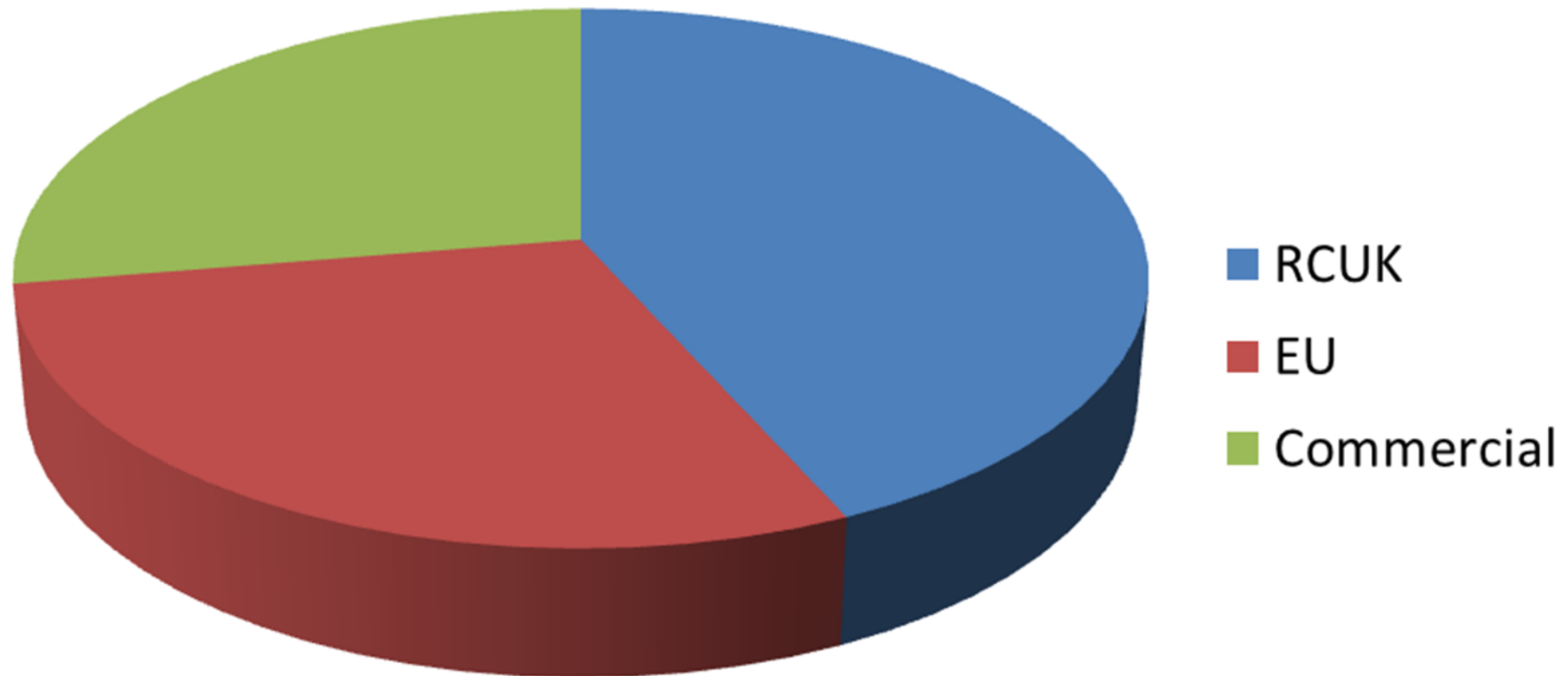


Companies & Organisations accessing the IBC in past 5 years include:



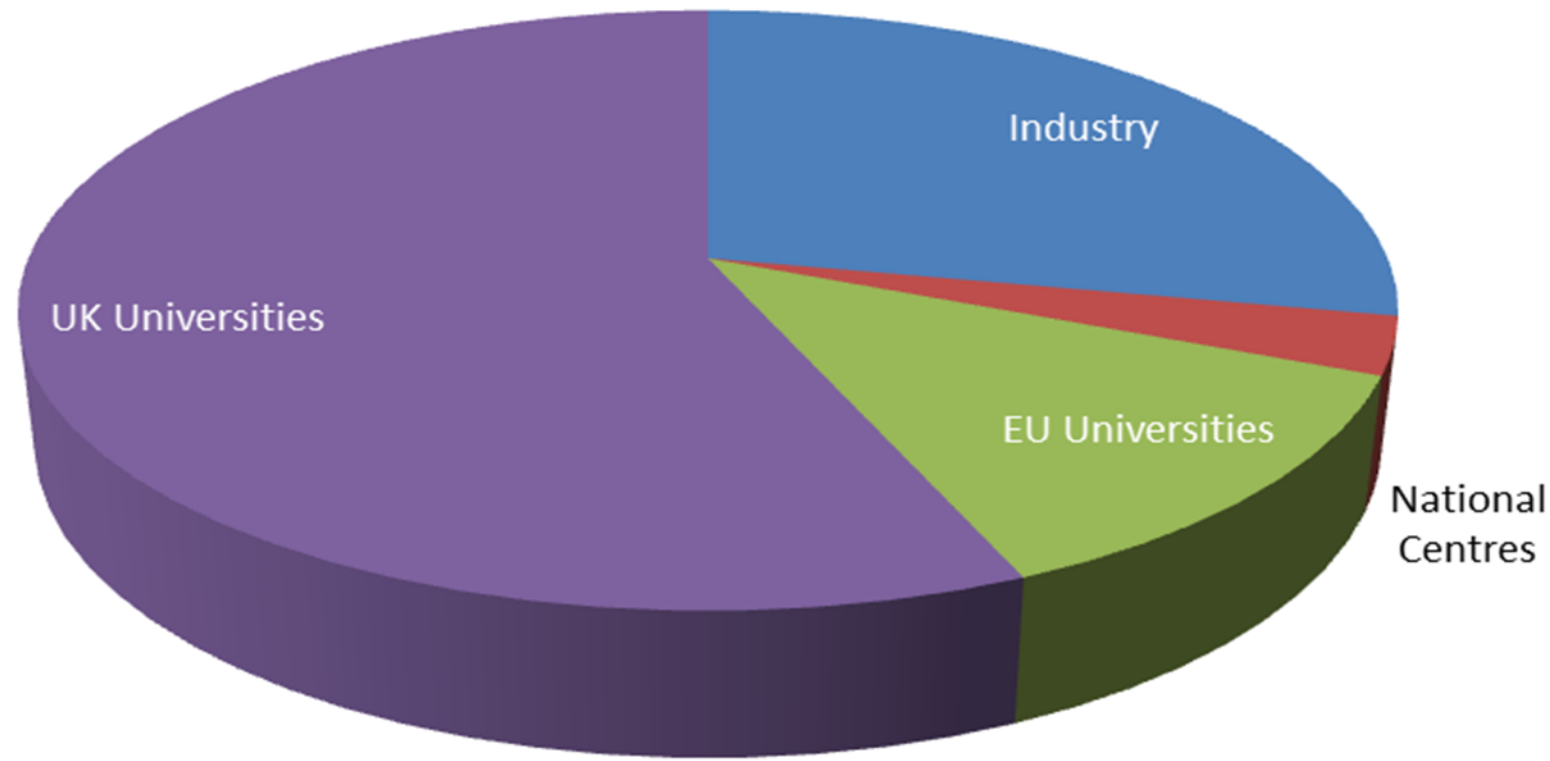
# Surrey Ion Beam Centre

*Breakdown of Funding at Surrey IBC over the past 5 years*



# Surrey Ion Beam Centre

*Breakdown of Beam Time Usage at Surrey IBC  
over the past 5 years*

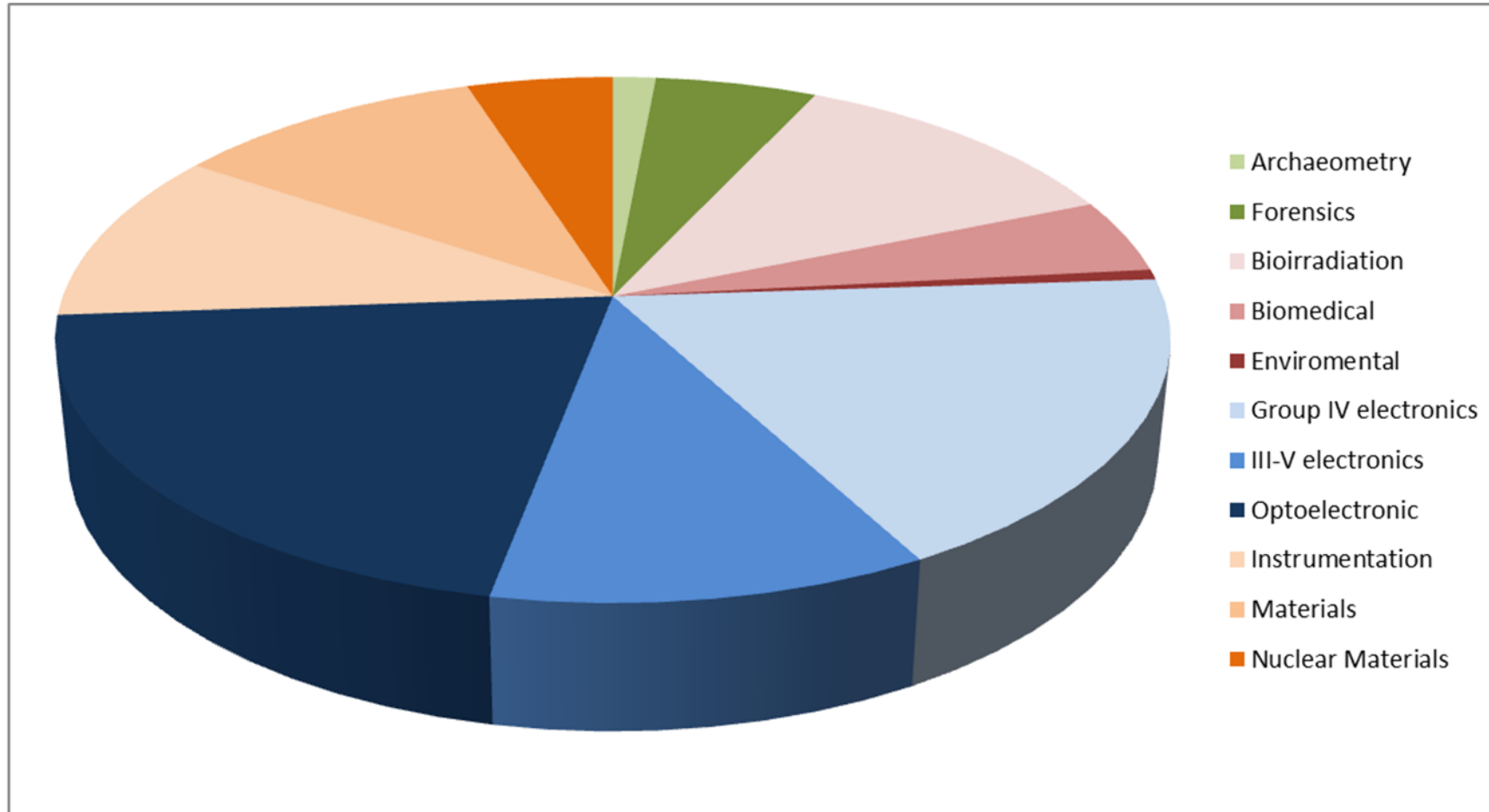




# Surrey Ion Beam Centre

## *Breakdown of Beam Time Used by Project Type*

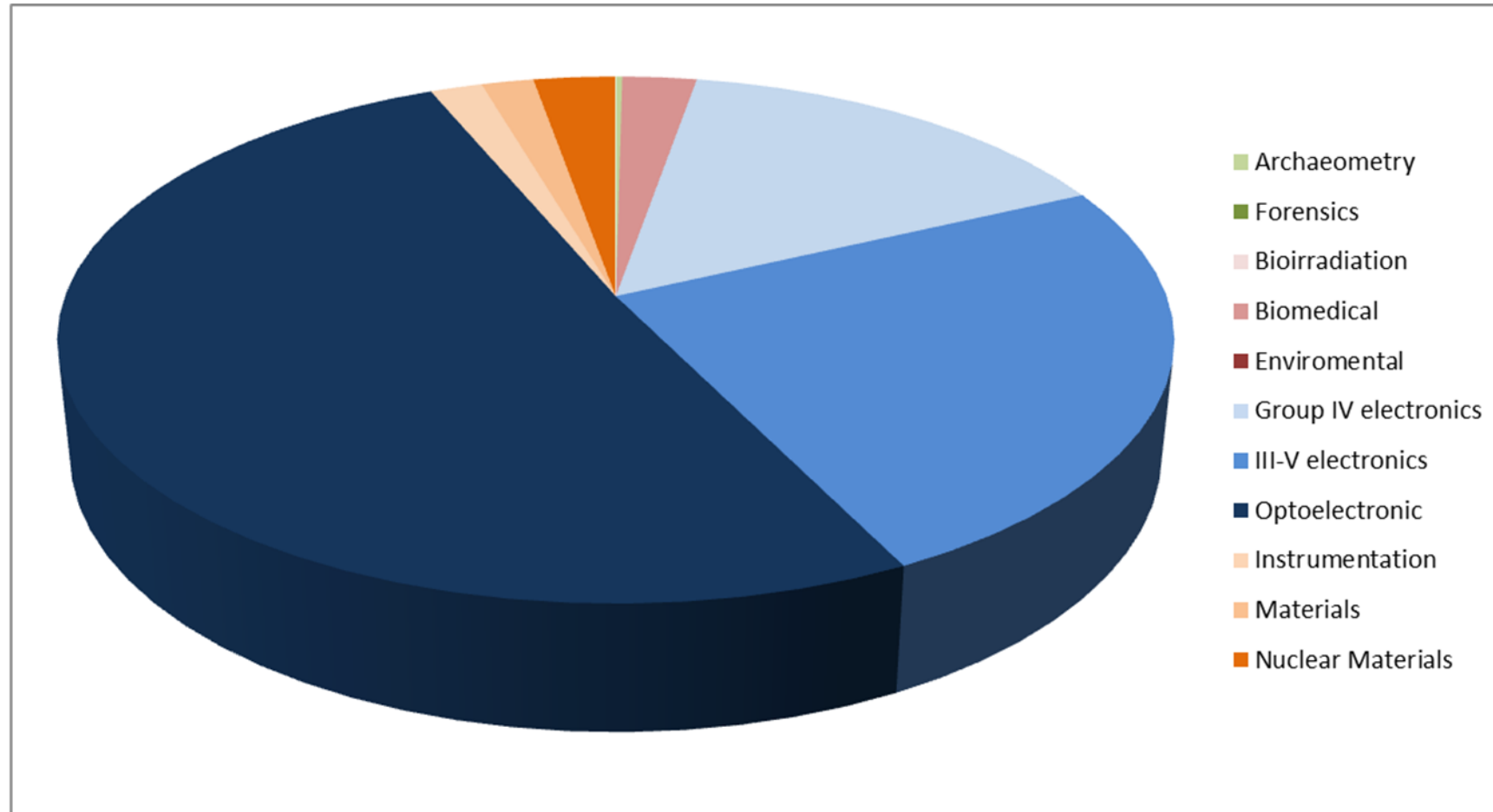
*All Funding Sources - 50% semiconductors*



# Surrey Ion Beam Centre

## *Breakdown of Beam Time Used by Project Type*

*Commercially Funded - 91% semiconductors*



## Future Developments:

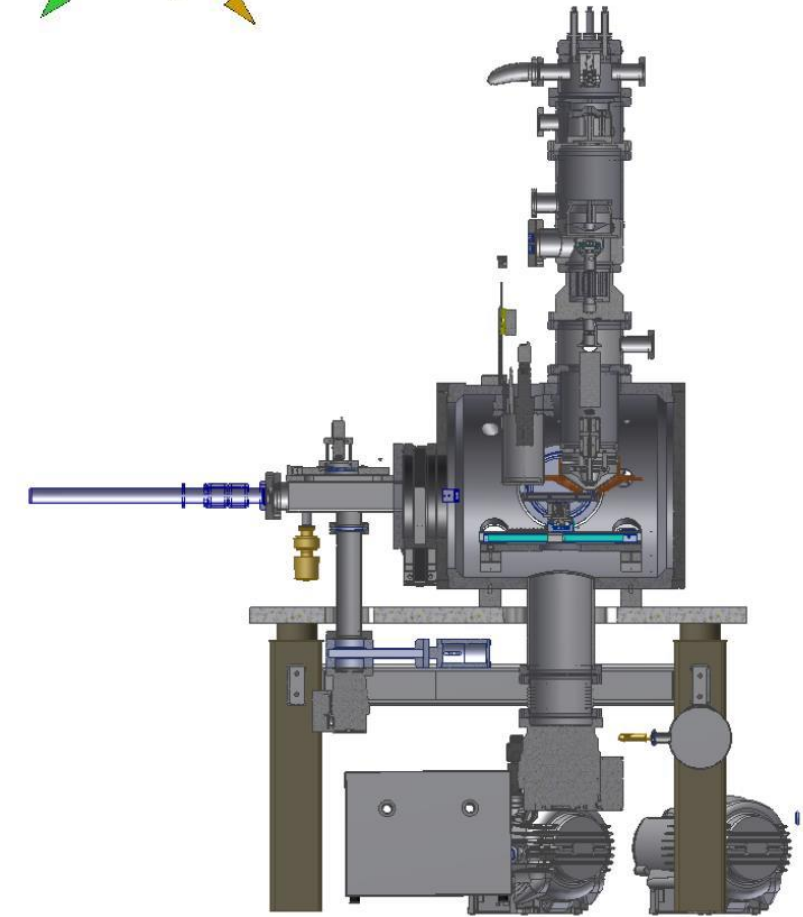
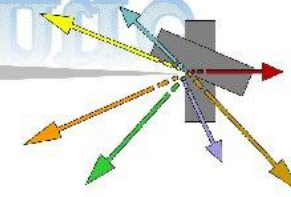
**SIMPLE** – Single Ion Implanter for Quantum Technology applications

**DAPNE** – 1 $\mu$ m molecular sampling attached to orbitrap MS coupled with 1 $\mu$ m trace element mapping

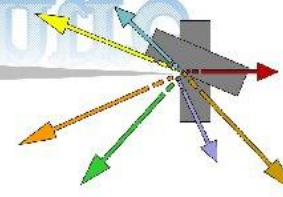
**Hot Cell** – installation in progress

**Dual beam end station** – in progress

**200mm beam line on 2MV implanter** – expected end 2017







## Getting Access:

There are five mechanisms through which users can gain access to these facilities:

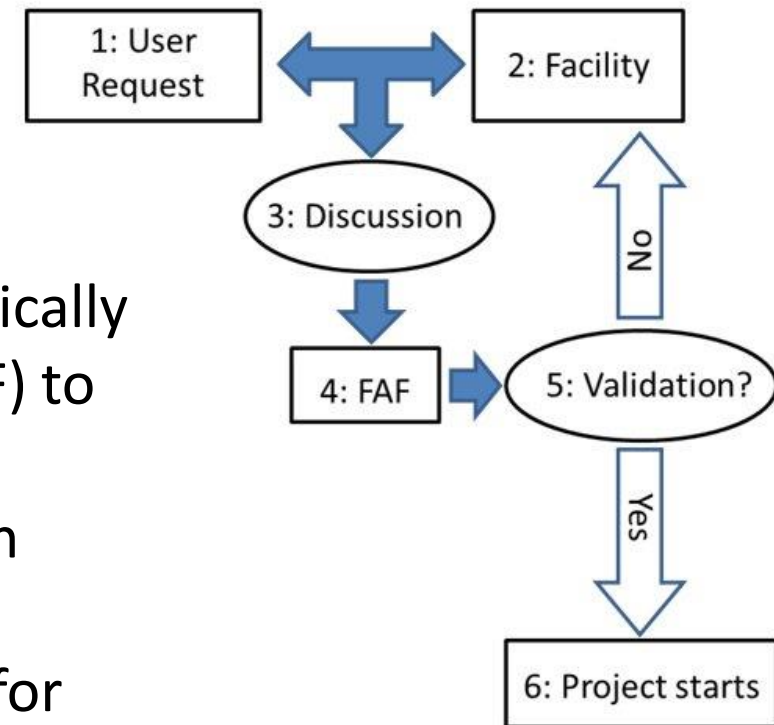
**Commercial** - the user pays for usage through the normal commercial route of each facility

**Existing EPSRC grants without time** - access granted via a simple validation process.

**New EPSRC Application** – access is requested as part of a EPSRC application. If the grant is awarded then access will be automatically provided by the UKNIBC – we supply Technical Assessment (FAF) to go with your application.

**EPSRC Students.** EPSRC funded students can access the UKNIBC in their own right.

**Pump Priming.** A proportion (10%) of UKNIBC time is earmarked for new projects that have no current EPSRC support.



## Summary

### Ion Implantation for Controllable Materials Modification

- 2keV – 4MeV energy range
- 10K to 1000K implant temperature
- Class 100 clean room

### Ion Irradiation for Radiation Damage studies

- in-situ TEM
- Hot Cell for active material irradiation

### Bio-irradiation for biological implications of radiation damage

- Vertical Beam line for irradiation in living cells in media
- Single ion delivery into single cell

### Ion Beam Analysis

- PIXE, EBS, RBS, ERD, PIXE, PIGE, NRA, IBIL, IBIC, MeV-SIMS
- in vacuum and in full ambient
- micro beams for mapping ~1um
- MEIS for high depth resolution

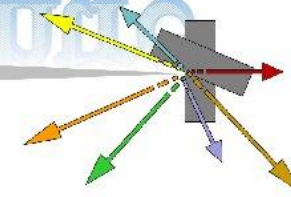
Available Implanted Species

2 - 2000kV

Not Available

Call

H	He																
Li	Be																
Na	Mg																
K	Ca	Sc	Ti	V	Cr	Mn	Fe	Co	Ni	Cu	Zn	Ga	Ge	As	Se	Br	Kr
Rb	Sr	Y	Zr	Nb	Mo	Tc	Ru	Rh	Pd	Ag	Cd	In	Sn	Sb	Te	I	Xe
Cs	Ba	Lu	Hf	Ta	W	Re	Os	Ir	Pt	Au	Hg	Tl	Pb	Bi	Po	At	Rn
Ra	Ac	Th	Pa	U	Np	Pu	Am	Cm	Bk	Cf	Es	Fm	Mn	No	Lr		
La	Ce	Pr	Nd	Pm	Sm	Eu	Gd	Tb	Dy	Ho	Er	Tm	Yb	Lu			
Ac	Th	Pa	U	Np	Pu	Am	Cm	Bk	Cf	Es	Fm	Mn	No	Lr			



**RBS**  
Energy of scattered protons or He give light element composition and elemental depth profiles

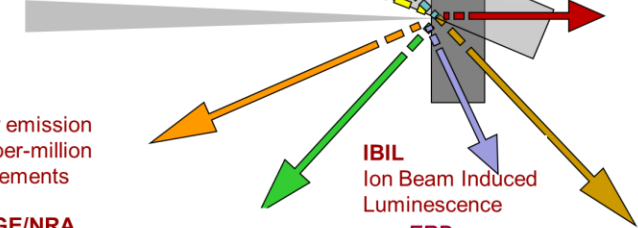
*Fast moving, charged particles MeV ions*

**PIXE**  
Characteristic X-ray emission Simultaneous part-per-million detection of trace elements from Na to U

**MeV-SIMS**  
Using heavy ions molecular material can be desorbed and analysed using ToF MS

**IBIC**  
Ion Beam Induced Charge

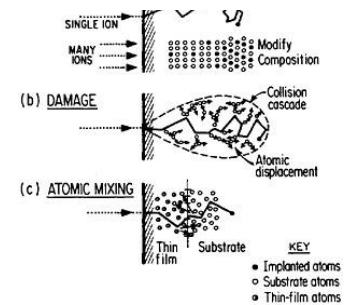
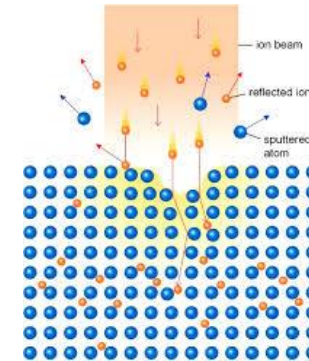
**STIM**  
Scanning Transmission Ion Microscopy



**IBIL**  
Ion Beam Induced Luminescence

**ERD**  
Forward recoil of target atoms (particularly good for H profiling)

**PIGE/NRA**  
Nuclear reactions give characteristic gamma rays and/or particles from light nuclei (e.g. Li, B, F)



### Surrey

- Implantation and Ion Beam Analysis facility

### Huddersfield

- Miami (in-line TEM) and MEIS facility

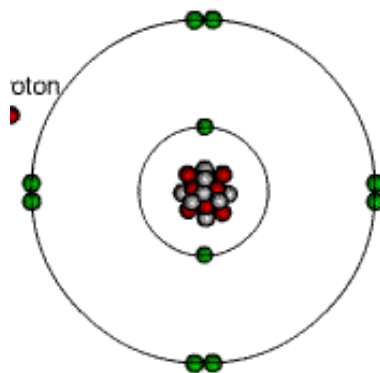
### Dalton Cumbrian Facility - Manchester

- Neutron irradiation emulation facility with hot cell

- Additional slides...

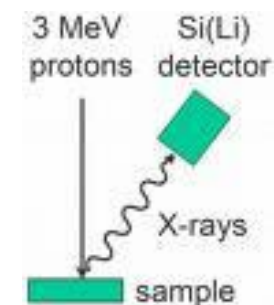
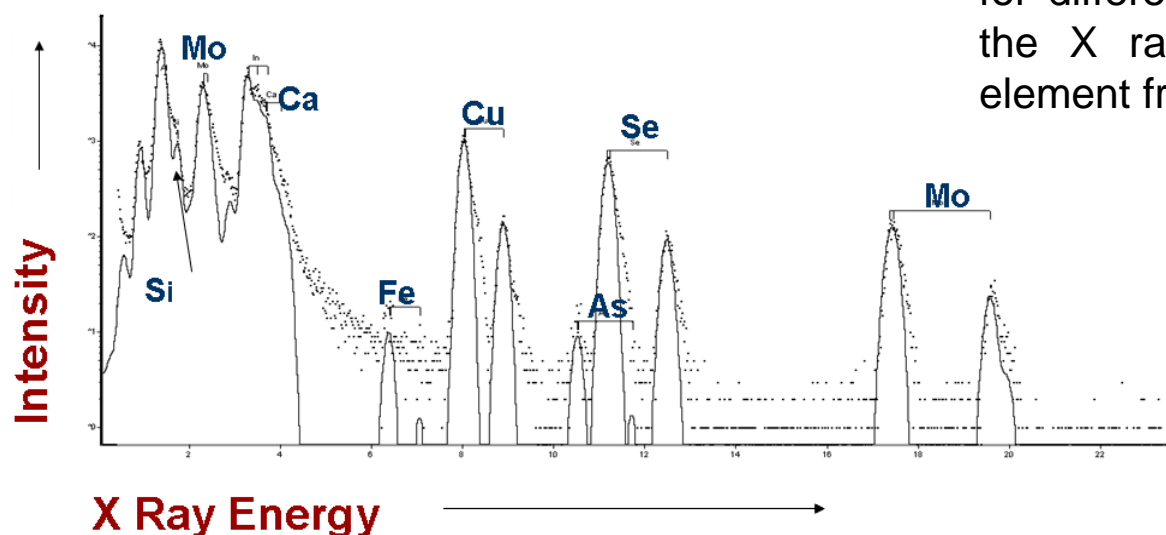


# What is PIXE...?



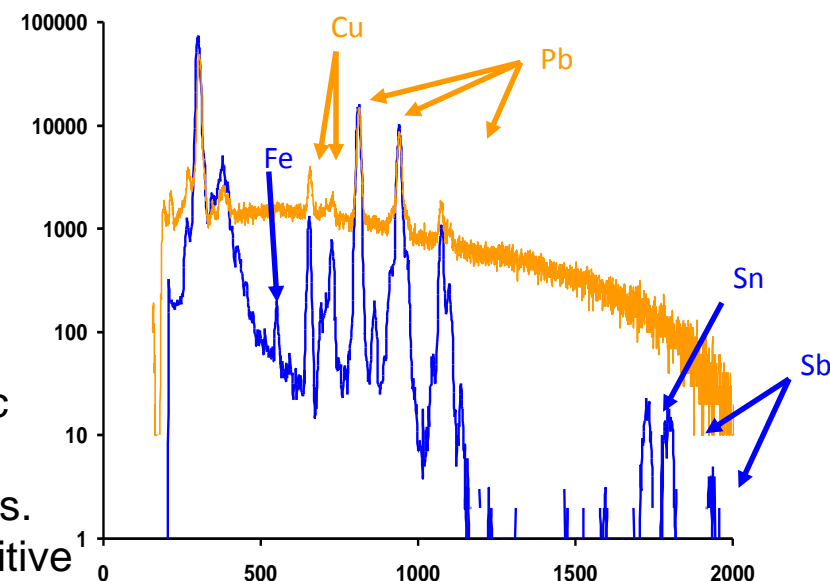
- The ion beam can cause ionisation of target atoms (i.e. the removal of an electron) as shown in the figure on the left.
- This leaves a vacancy in one of the electron shells
- An electron from an outer electron shell jumps down to fill the gap
- An X ray is emitted, the energy of which is equal to the difference in the energy levels.
- Since different atoms have a different number of protons, the spacing of the energy levels for different atoms is different, and therefore the X ray energy is characteristic of the element from which it originated

## Particle Induced X-ray Emission



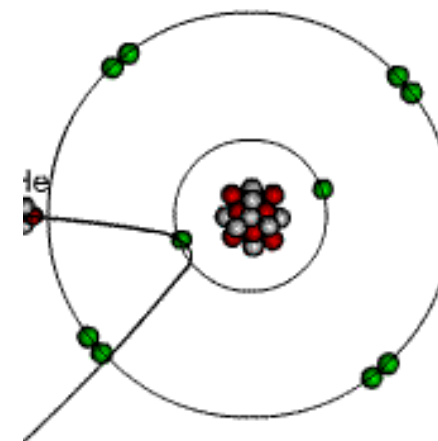
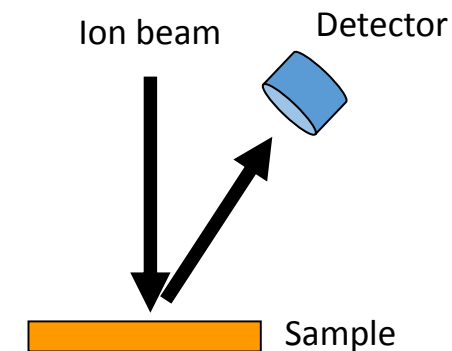
# Benefits of PIXE & PIGE

- PIXE can be used to detect elements in the periodic table **from Na to U (Li, B, F etc. with PIGE)**
- The sensitivity is at the **ppm level** for most elements.
- The figure on the right shows how much more sensitive PIXE (blue) is to trace elements than the electron microprobe (yellow), **no brehmsstrahlung**
- The analysis can be carried out **in air or in vacuum**. This allows the non-destructive analysis of large and/or vacuum sensitive objects.
- There is usually **no need for any sample preparation**
- PIXE analysis gives absolute quantification. There is no need to compare to standards.
- The accuracy of the technique is ~5%.
- In PIXE analysis, we simultaneously collect a backscattered particle spectrum. This gives us complementary information that we can use to determine depth profiles of the major elements.



# What is RBS?

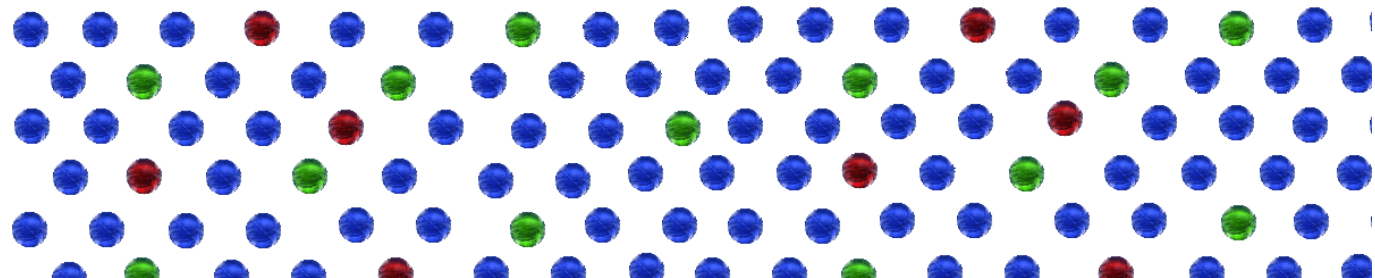
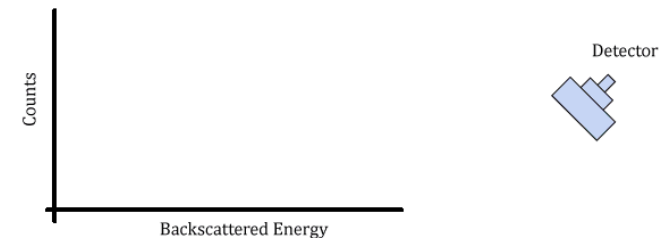
- RBS determines compositional information about a sample:
  - **Which** atoms are present and **where** are they?
- Rather than an alpha source like Rutherford, we use a more convenient ion beam from an accelerator
- We detect backscattered particles and their energy
- Ions are repelled by the positively charged nucleus, and scattered backward.
- The particle detector measures the energy of the backscattered particles.
- For high beam energies (EBS) the ion penetrates the nucleus, and the scattering probability is modified.





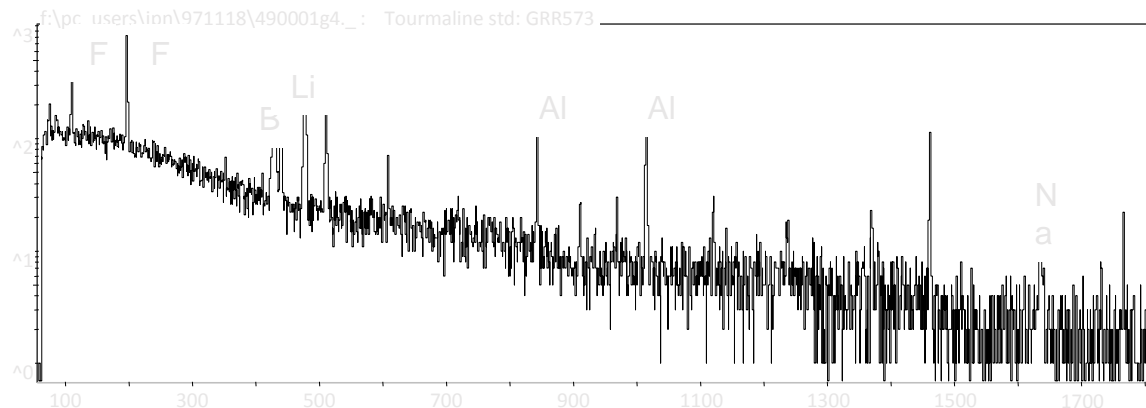
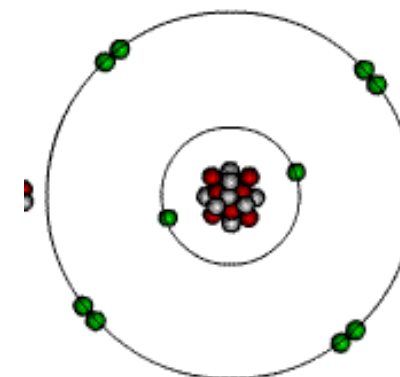
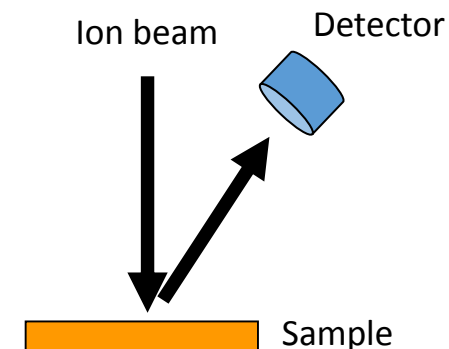
# How to interpret a RBS Spectra

- The energy of the backscattered particle depends on the depth in the sample at which it was backscattered
- As the particle travels through the sample, it loses energy through collisions with the target electrons
- These collisions don't really affect the particle's direction, just its speed (i.e. kinetic energy)
- The energy of the backscattered particle also depends on the mass of the atom it hit
- If it hits a heavy atom, it rebounds at high energy
- If it hits a light atom, it rebounds with lower energy

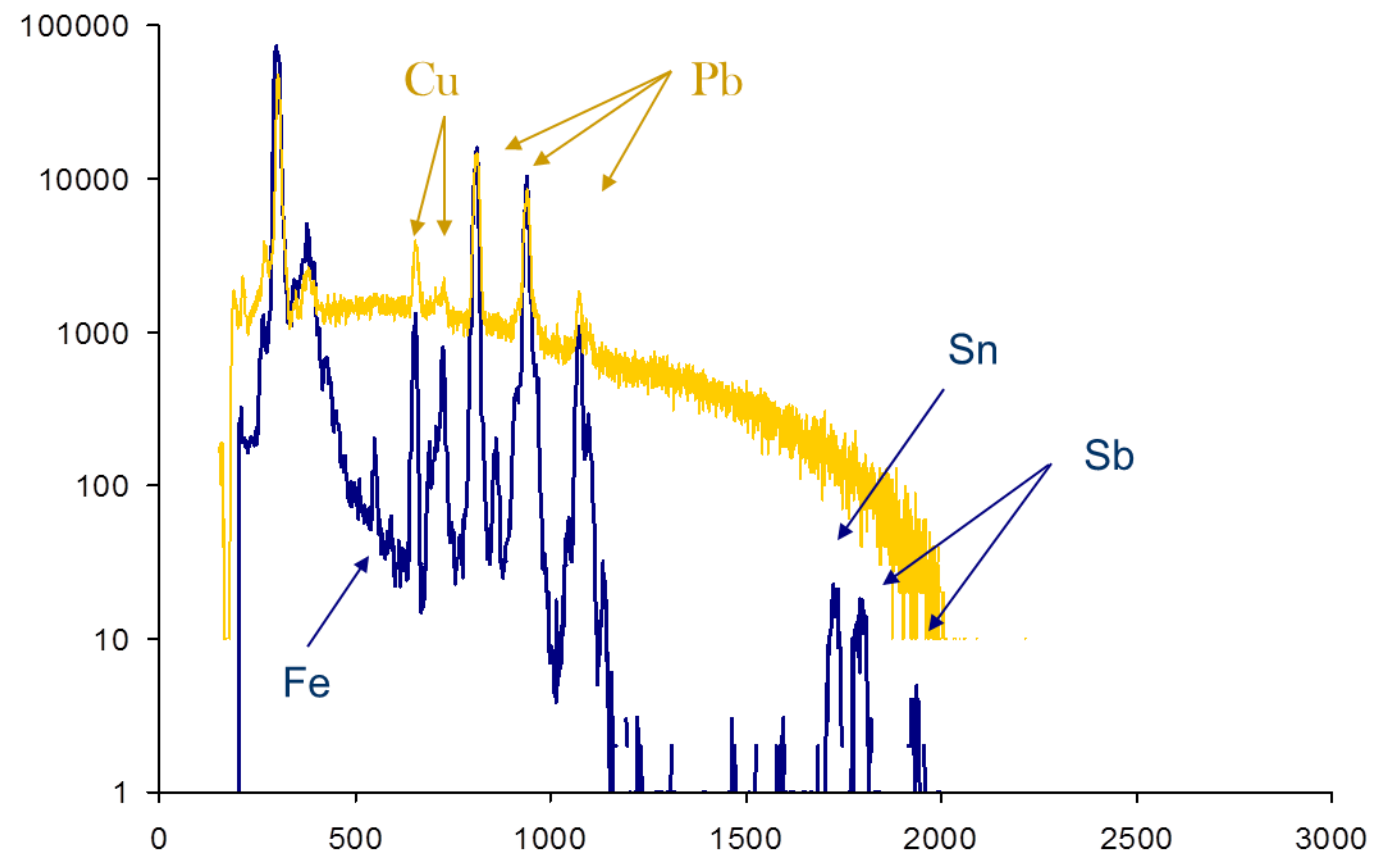
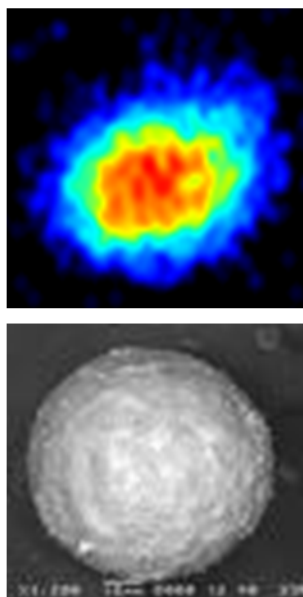


# What is NRA/PIGE?

- **NRA or Nuclear Reaction Analysis** uses accelerated nuclei to penetrate the nucleus of a target atom causing a nuclear reaction in the target nucleus and the emission of a particle (or a gamma ray in **PIGE**) whose energy is characteristic of the target element.
- The technique is particularly useful for **identifying light elements** that are difficult to “see” with PIXE.
- **Resonant reactions** can be used which occur at particularly sharp interaction energies. As the mono-energetic beam slows gradually as it enters the target, these resonant reactions occur only at determinable depths. Hence by varying the energy of the initial beam it is possible to **depth profile** using this technique.

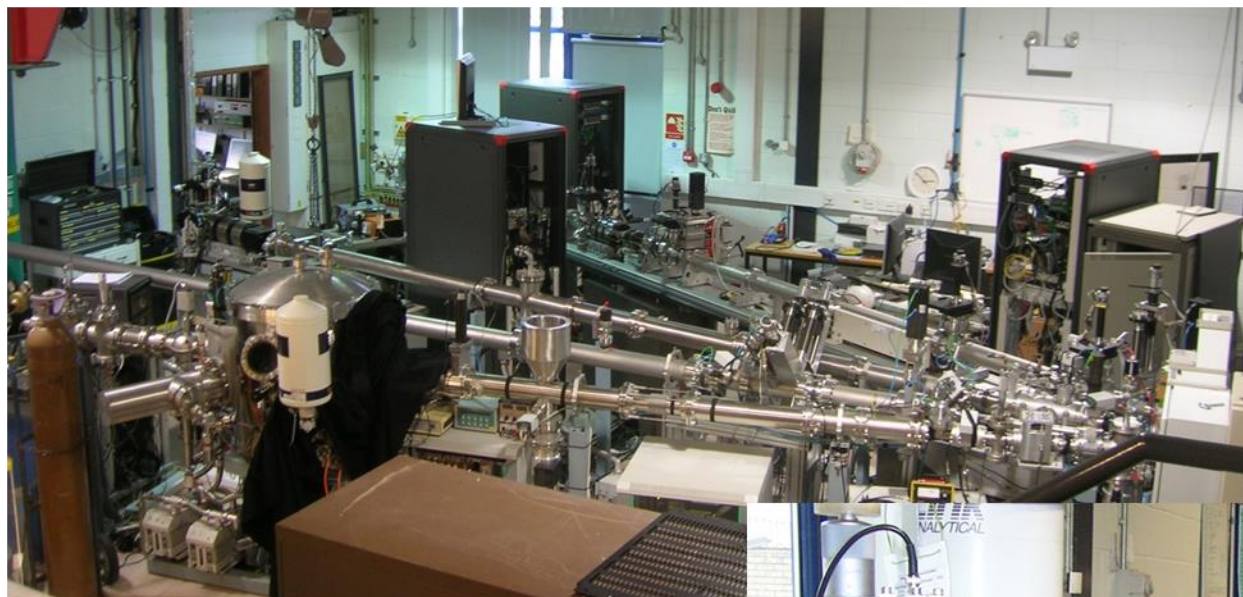


# Ion Beams vs Conventional Methods





# Ion Beam Mapping



Ions from  
accelerator



Magnets for  
focussing

